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PATENT APPLICATION

THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hidekazu MORIYAMA

Group Art Unit: 1746

Application No.: 10/827,426

Filed: April 20, 2004

Docket No.: 119295

For: CLEANING METHOD, STORAGE METHOD, PATTERN FORMATION METHOD,
DEVICE MANUFACTURING METHOD, ELECTRO-OPTICAL DEVICE, AND
ELECTRONIC APPARATUS

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

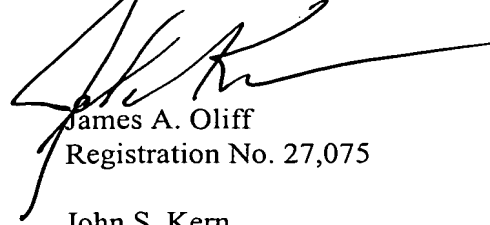
Sir:

Pursuant to 37 CFR §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached PTO-1449. Unless otherwise indicated herein, one copy of each reference is attached. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

- ☒ 1. This Information Disclosure Statement is being filed (a) within three months of the U.S. filing date of this non-CPA application, OR (b) before the mailing date of a first Office Action on the merits in the present application. No certification or fee is required.
- ☒ 2. In accordance with 37 CFR §1.98(a)(2)(ii), copies of any U.S. patents and patent application publications are not attached.

- ☒ 3. Reference 1 corresponds to reference 2.

Respectfully submitted,



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JAO:KLK/jeh

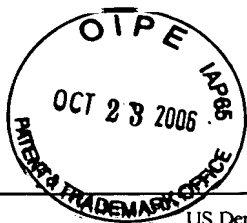
Date: October 23, 2006

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Sheet 1 of 1Form PTO-1449
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PATENT & TRADEMARK OFFICEATTY DOCKET NO.
119295APPLICATION NO.
10/827,426

INFORMATION DISCLOSURE STATEMENT

(Use several sheets if necessary)

APPLICANT(S)
Hidekazu MORIYAMAFILING DATE
April 20, 2004GROUP
1746

U.S. PATENT DOCUMENTS

| Examiner Initials | Cite No. | Document Number | Date | Name |
|----------------------|-------------|-----------------|------------|-----------------|
| | 1 | 6,830,855 | 12/14/2004 | Kiguchi, et al. |
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FOREIGN PATENT DOCUMENTS

| Examiner Initials | Cite No. | Document Number | Date | Country | With English Abstract | With English Translation |
|----------------------|-------------|-----------------|-----------|---------|-----------------------------|--------------------------------|
| | 2 | CN 1393704A | 1/29/2003 | China | | |
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OTHER DOCUMENTS

| Examiner Initials | Cite No. | (Including Author, Title, Date, Pertinent Pages, etc.) |
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EXAMINER

DATE CONSIDERED

Examiner: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.